

Dkt. 2271/66770

1734
#5

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant of : Hideyuki YAMAGUCHI

Serial No. : 10/075,481

Group Art Unit: 1734

Date Filed : February 13, 2002

Examiner:

For : HEAT-SENSITIVE STENCIL SHEET AND METHOD OF MAKING
THE SAME

1185 Avenue of the Americas
New York, N.Y. 10036

Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

RECEIVED
JUL 3 - 2002
TC 1700

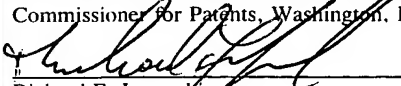
Sir:

The information listed in the attached form PTO-1449 is brought to the attention of the Examiner. Copies of the information identified herein are also provided.

It is respectfully requested that the information cited in annexed Form PTO-1449 be considered by the Examiner in connection with the above-identified patent application, and that such art be made of record in said application.

The citation of the listed items is not a representation that they constitute a complete or exhaustive listing of the relevant art or that these items are prior art. The items listed are submitted in good faith, but are not intended to substitute for the Examiner's search. It is

I hereby certify that this paper is being deposited this date with the
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Richard F. Jaworski
Reg. No. 33,515

June 25, 2002
Date

hoped, however, that in addition to apprising the Examiner of the particular items, they will assist in identifying fields of search and in making as full and complete a search as possible.


The filing of this Information Disclosure Statement is not an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

To the best of Applicants knowledge, this Information Disclosure Statement is being filed before the date of mailing of a first Office Action on the merits in connection with this case.

The Office is hereby authorized to charge any additional fees which may be required for consideration of this Information Disclosure Statement and to credit any overpayment to our Deposit Account No. 03-3125.

Early and favorable consideration of the case is respectfully requested.

Respectfully submitted,


RICHARD F. JAWORSKI
Registration No. 33,515
Attorney for Applicants
Cooper & Dunham LLP
Tel. (212) 278-0400

Form PTO-1449	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 2271/66770	Serial No. 10/075,481
INFORMATION DISCLOSURE CITATION BY APPLICANT (Use several sheets if necessary)		Applicant Hideyuke YAMAGUCHI	
		Filing Date February 13, 2002	Group 1734

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number							Date	Name	Class	Subclass	Filing Date if Appropriate
	AA	5	7	0	7	7	1	2	January 13, 1998	Fujimura et al.			
	AB	5	0	9	1	2	5	7	February 25, 1992	Nonogake et al.			
	AC												
	AD												
	AE												
	AF												
	AG												
	AH												
	AI												
	AJ												
	AK												

FOREIGN PATENT DOCUMENTS

		Document Number							Date	Country	Class	Subclass	Translation	
													Yes	No
	AL	3	1	9	3	4	4	5	August 23, 1991	Japan			ABST.	
	AM	6	2	1	9	8	4	59	September 2, 1987	Japan			ABST.	
	AN	3	2	4	0	5	9	6	October 25, 1991	Japan			ABST.	
	AO	5	4	0	3	3	1	17	March 10, 1979	Japan			ABST.	

EXAMINER

DATE CONSIDERED

***EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449

U.S. Department of Commerce
Patent and Trademark OfficeAtty. Docket
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(Use several sheets if necessary)Applicant
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													Yes	No
	AP	9	0	5	2	4	6	9	February 25, 1997	Japan			ABST.	
	AQ	1	1	3	0	9	9	54	November 9, 1999	Japan			ABST.	
	AR	8	3	3	2	7	8	5	December 17, 1996	Japan			ABST.	
	AS	1	0	2	4	6	6	7	January 26, 1989	Japan			ABST.	
	AT	1	1	2	3	5	8	85	April 16, 2002	Japan			ABST.	
	AU	1	0	1	4	7	0	75	June 2, 1998	Japan			ABST.	
	AV	1	0	2	3	6	0	11	September 8, 1998	Japan			ABST.	
	AW	1	0	1	4	7	0	75	June 2, 1998	Japan			ABST.	
	AX	1	1	2	3	5	8	55	August 31, 1999	Japan			ABST.	

EXAMINER

DATE CONSIDERED

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